



Justervesenet

USN University of
South-Eastern Norway

NPL
National Physical Laboratory



Optical pulse-drive and on-chip power splitter for the pulse-driven AC Josephson voltage standard

(Josephson Arbitrary Waveform Synthesizer : JAWS)

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1: Physikalisch-Technische Bundesanstalt PTB, Braunschweig, Germany

2: Justervesenet JV, Kjeller, Norway

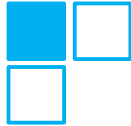
3: University of South-Eastern Norway USN, Horten, Norway

4: National Physical Laboratory NPL, Teddington, United Kingdom



This work was partly carried out with funding by the European Union within the EMPIR 15SIB04 QuADC and by the German Federal Ministry of Economic Affairs and Energy due to a decision of the German Bundestag (ZIM).

The EMPIR is jointly funded by the EMPIR participating countries within EURAMET and the European Union.



Outline



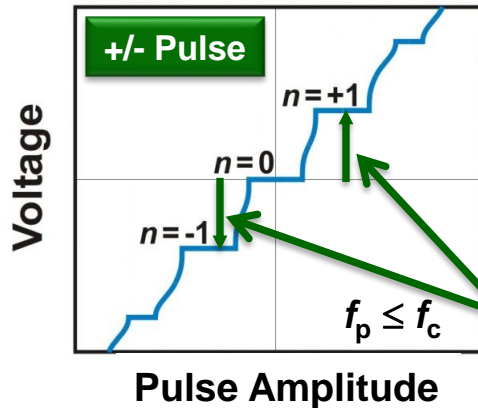
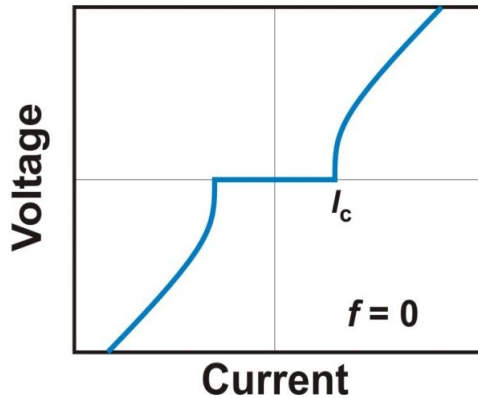
- 1. JAWS basics**
- 2. JAWS at PTB : status quo**
- 3. 5-stacked Josephson junctions arrays**
- 4. optical pulse-drive**
- 5. on-chip power splitter**



JAWS : basics (I)

**SNS junctions :
 non-hysteretic IVC**

S: Superconductor / N: normal metal



**Shapiro-step :
 selected by
 pulse amplitude**

$f_{\text{clock}} = 15 \text{ GHz}$
 RTZ pulses (30 Gbit/s)

a current pulse (**pulse repetition frequency f_p**)
 transfers N flux-quanta $\Phi_0 = h/2e$
 through M Josephson junctions.

signal voltage

**Josephson equation
 in pulse-mode operation :**

$$V_{\text{signal}}(t) = M \cdot N \cdot \Phi_0 \cdot f_p(t)$$

(Shapiro steps for $f_p \leq f_c$)

signal frequency

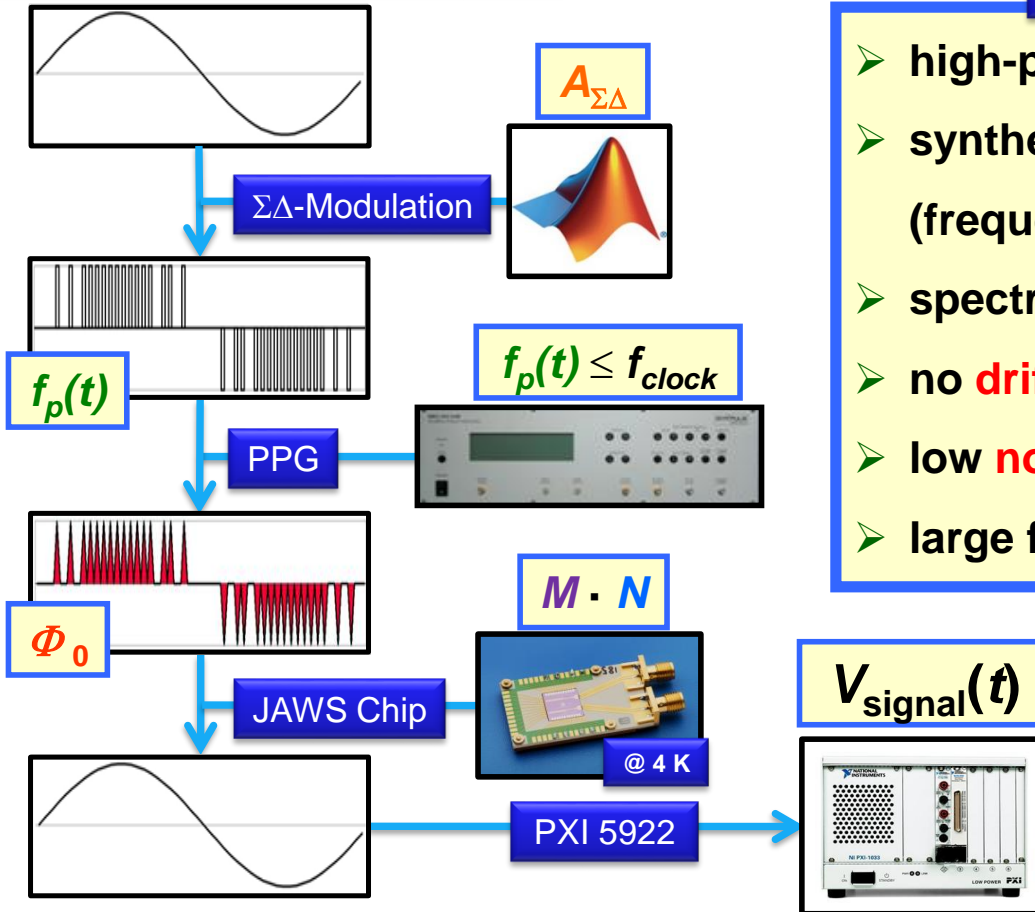
$$f_{\text{signal}} = T_{\Sigma\Delta} \cdot f_{\text{clock}} / L_{\Sigma\Delta}$$

- $A_{\Sigma\Delta}$: code amplitude
- $T_{\Sigma\Delta}$: number of periods
- $L_{\Sigma\Delta}$: code length
- $\Phi_0 \approx 2 \mu\text{V}/\text{GHz}$

JAWS principle : S.P. Benz and C.A. Hamilton, *APL* 68 (1996) 3171

JAWS : basics (II)

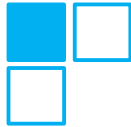
arbitrary waveform



quantized waveform

Quantum - Standard

- high-precision **quantized** AC voltage source
- synthesis of **arbitrary** waveforms (frequency or time domain)
- spectrally **pure** waveforms (SNR > 130 dBc)
- no **drift**
- low **noise**
- large frequency **bandwidth** (DC ... MHz)



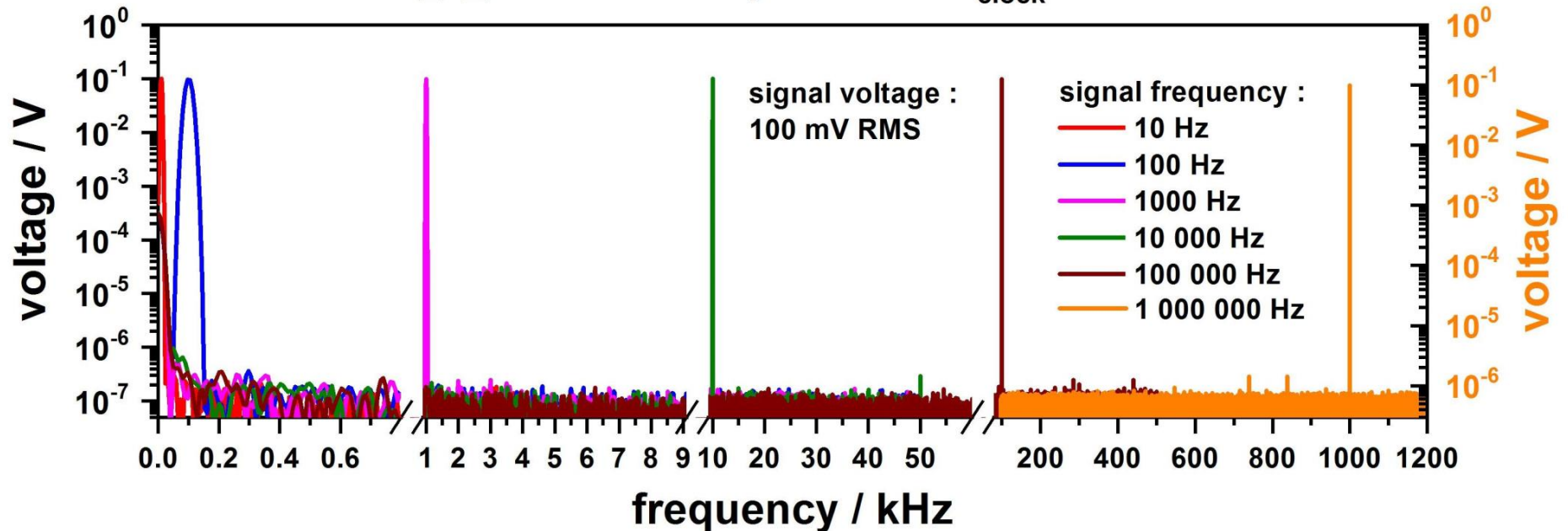
bandwidth / arbitrary / precision



large frequency bandwidth : 1 Hz...1 MHz



JAWS23_3_C1#1 : 12 000 junctions / $f_{\text{clock}} = 13 \text{ GHz}$



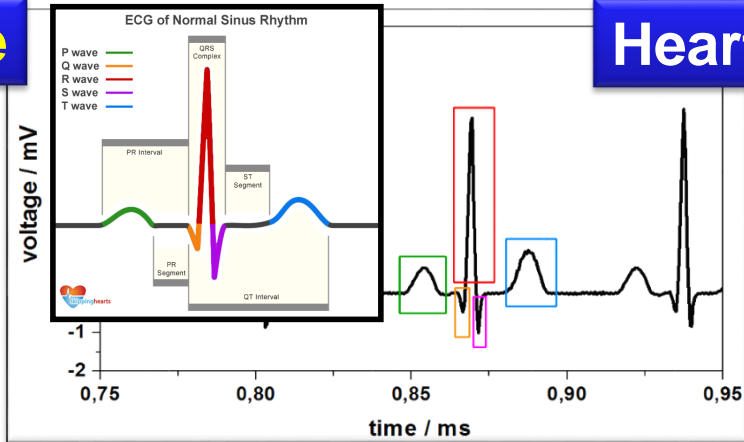
waveform : sinus
amplitude : 100 mV RMS

bandwidth / arbitrary / precision



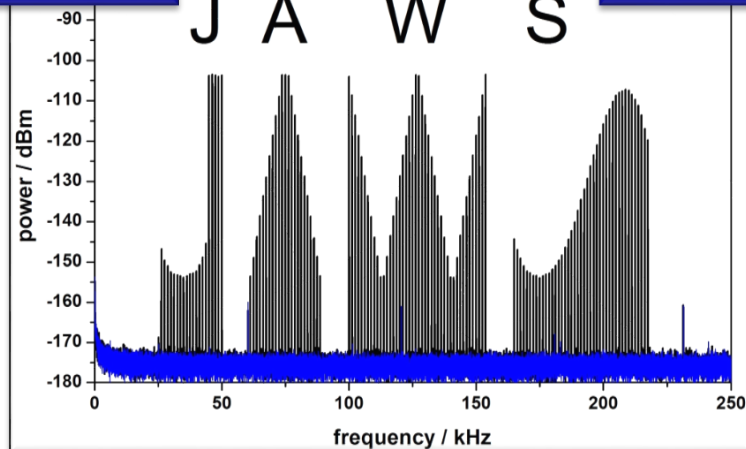
arbitrary frequency and time domain

time



Heartbeat

frequency



JAWS

Quantum precision

1 V RMS comparison:

$$V_{\text{JAWS}} - V_{\text{QVM}} = (+3.5 \pm 12) \text{ nV @ 250 Hz}$$

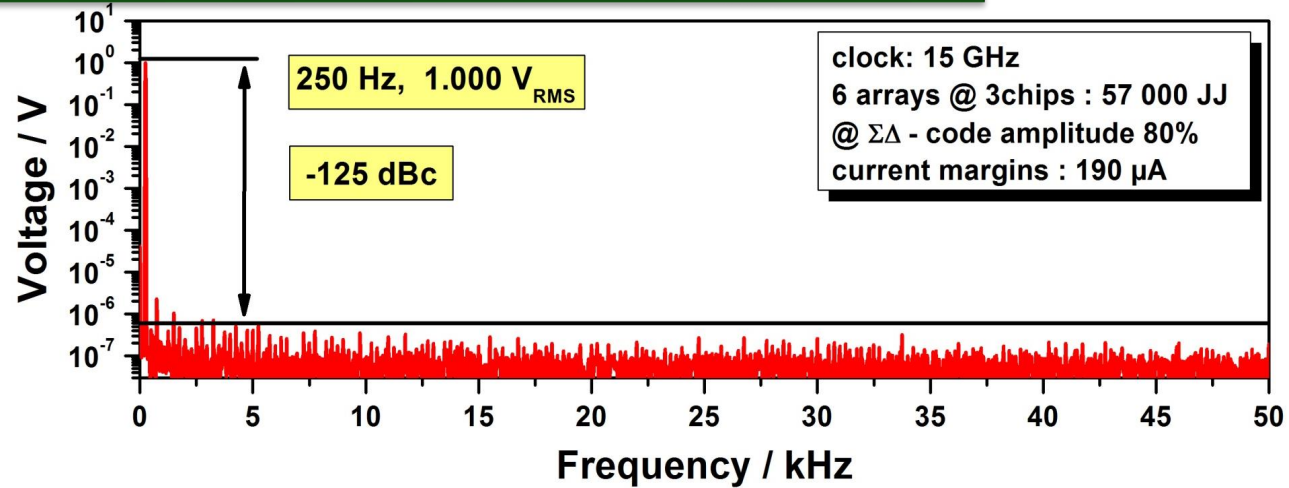
Behr et al., *Metrologia* 2015

Highlight paper of
Metrologia in 2015 !

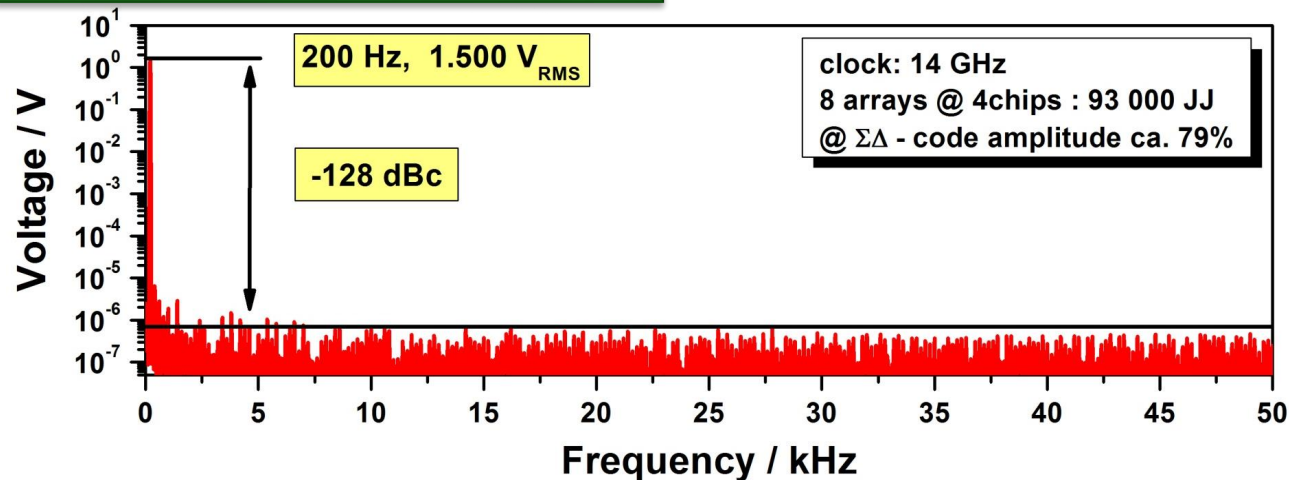
Recently : higher integration density



57 000 junctions @ 3 chips (instead of 4)



93 000 junctions @ 4 chips



1 V RMS

established (high yield) :

- 4-stacked junctions
- 24 000 junctions / chip

1.5 V RMS

1.5 V JAWS-System : 93 000 junctions



cryoprobe

8 Arrays @ 4 Chips

PXI 5922

8 channel PPG

8 channel compensation

LabView

control and measurement

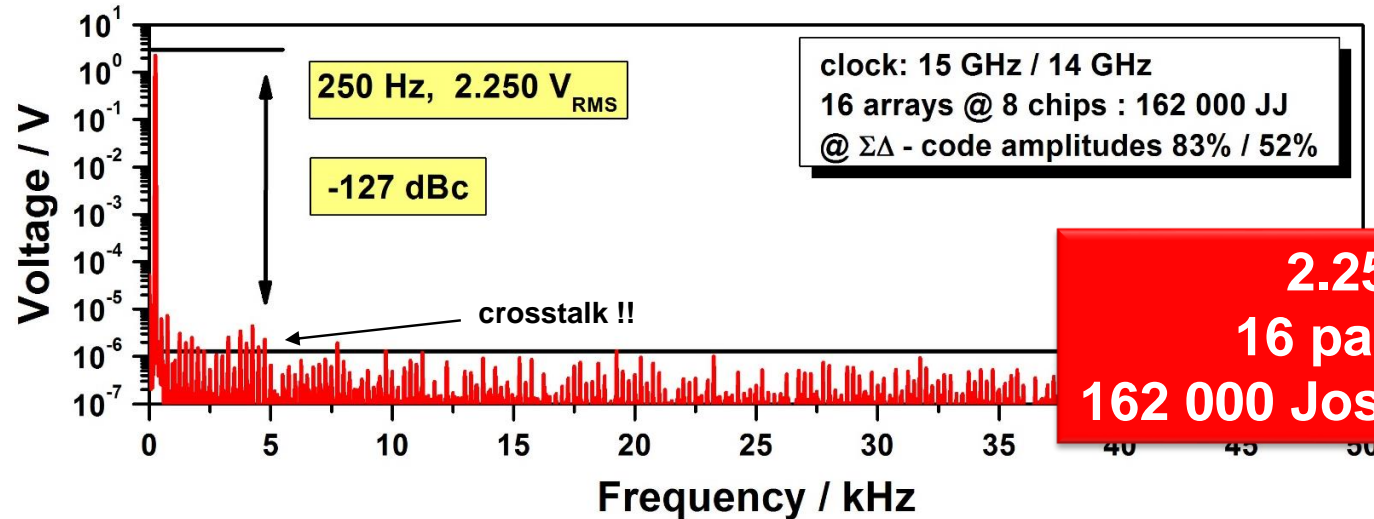
cryoperm shield

3. generation carrier

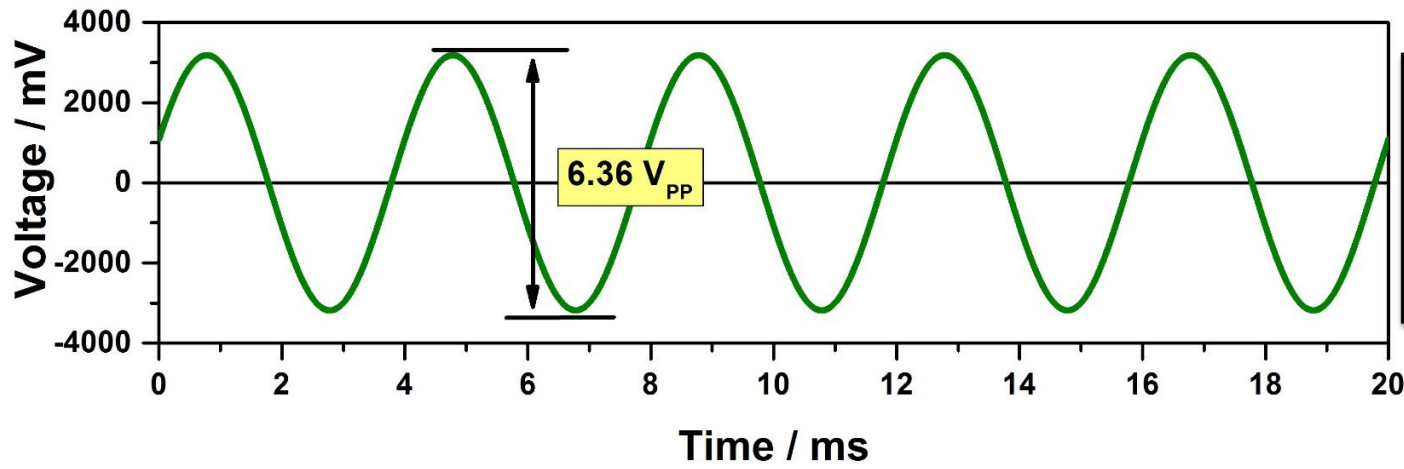
1.5 V JAWS-System

**6 JAWS-Systems @ PTB
in daily use for applications**

2017 : 2.25 V RMS demonstrated

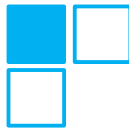


**2.25 V RMS :
16 parallel arrays
162 000 Josephson junctions**



**NIST @ CPEM 2018 :
4 V RMS
16 parallel arrays
204 960 junctions
(4 HF channels)**

**2.25 V RMS →
ca. 1 088 000 000 000 000 Φ_0 per second**



Impact 2018 : JAWS applications



12 x CPEM 2018 - contributions with JAWS → coauthor



Conference on
Precision
Electrical
Measurement



most important
Metrology
conference

PTB

1. Bauer
2. Behr
3. Herick
4. Kohlmann
5. Kraus
6. Palafox

with external partners

7. de Aguilar 
8. Ireland 
9. Lapuh 
10. Nissilä 
11. Sira 
12. Sosso 

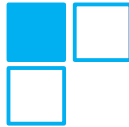
most
measurements
made @ PTB



QUADC













JNT - JAWS

6 other contributions (2xASC 2018, etc.)



Examples of Activities (@ PTB)



- 1 V JAWS : **AC-DC transfer** measurements with trans-conductance amplifier (NMIA) 
- 1 V JAWS : characterization of **Keysight 3458A** (SIQ, CEM)   
- AC-DC transfer (**up to 1 MHz**) with **Fluke792A** in mini-cryostat (VSL) 
- Characterization of **ADC's** (CMI) 
- Systematic **error analysis** (Tubitak) 
- Impedance/quadrature bridge** (vs. AC-QHE, cryocooler)
- JAWS based **μ V-Synthesizer** (pV/junction)
- JAWS with **optical pulse-drive** (NPL, JV, VTT)  
- JAWS **JNT** (with PTB Berlin) 
- JAWS in **cryocooler** (INRIM) 
- Characterization of **Voltage Divider** 

EU projects:
EMRP „Q-WAVE”
EMPIR „ACQ-PRO”
EMPIR „QuADC”

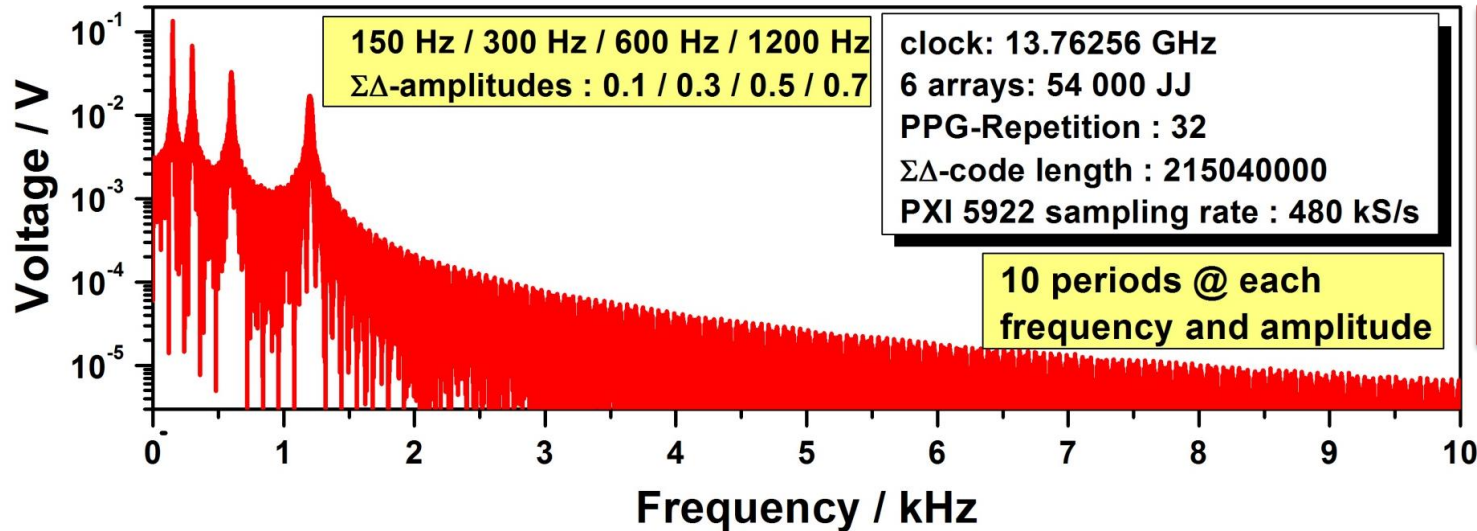


11

Application : characterization ADC (I)



“Martin Sira” 4x4x10-Waveform : 4 x f, 4 x A, 10 x T

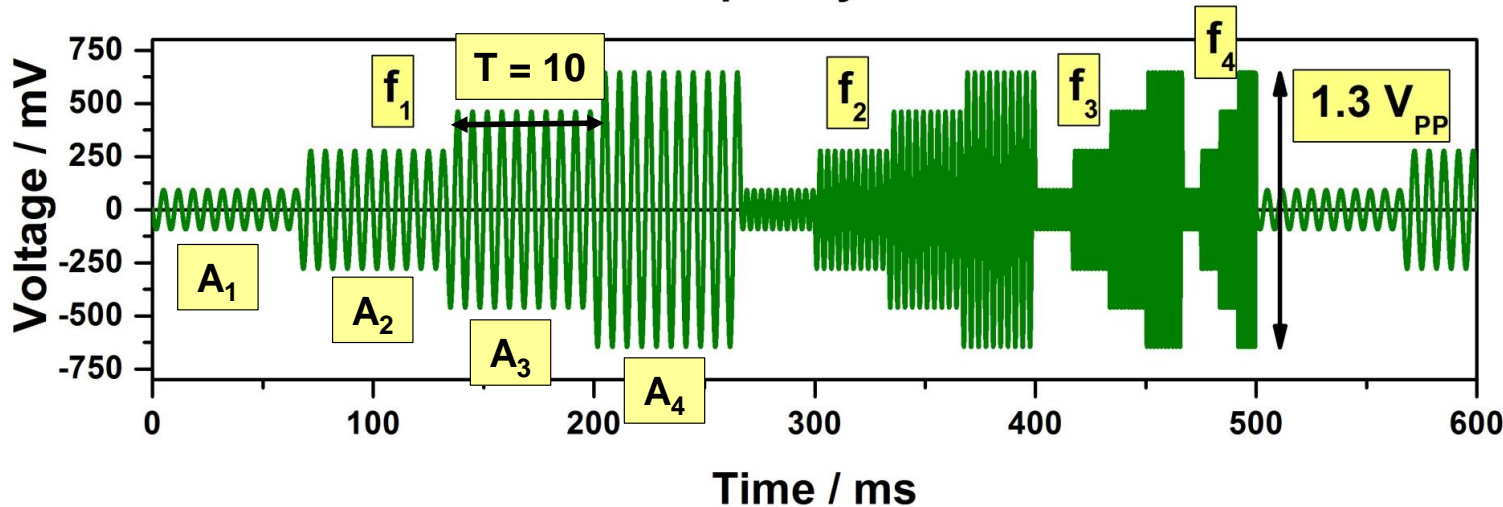


special waveform :

- 4 frequencies
- 4 amplitudes
- 10 periods each

„simultaneously“ analyzed :

- gain (amplitude)
- frequency response
- time stability



M. Sira et al.
@ CPEM 2018

PTB JAWS Chips @ 8 countries



distributed within
international research projects

National Metrology Institutes

-  1. Netherland
-  2. United Kingdom
-  3. Norway
-  4. Italy
-  5. Finland
-  6. Turkey
-  7. Russia
-  8. China



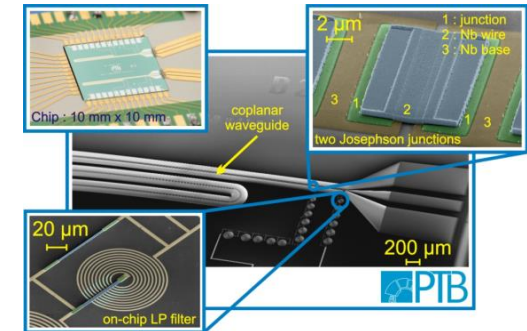
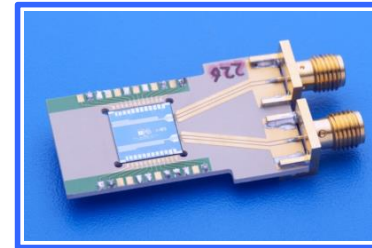
JOSY

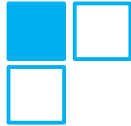


JAWS



QUADC





Odyssey goes on...



...JAWS AND BEYOND...



<http://www.listal.com/viewimage/5873313>

overview : recent projects / goals



JAWS with higher voltage : 7...10 V RMS

- more Josephson junctions @ chip
- less chips → **less HF-channels @ 300 K**
- less HF-crosstalk
- parallel-operation on-chip :
 - optical pulse → photodiodes @ 4.2 K
 - power-splitter on-chip @ 4.2 K



JAWS system:

- less complex
- less expensive
- more user-friendly

AIST and NIST : pioneer work !

▪ Urano, et al., SUST, 2009

▪ Flowers-Jacobs, et al., IEEE TAS, 2016

▪ Yamamori et al., IEEE TAS, 2016

few junctions, work stopped

UNIVEX 450C – Cluster - Sputter - System



SNS junctions : Nb_xSi_{1-x}

Nb_xSi_{1-x} parameter for
70 GHz and 15 GHz

6 chambers

fully automatic

2xNb, Si, AuPd,
HfTi, Al, Al_2O_3
rf-cleaning

SNS / SIS / SINIS

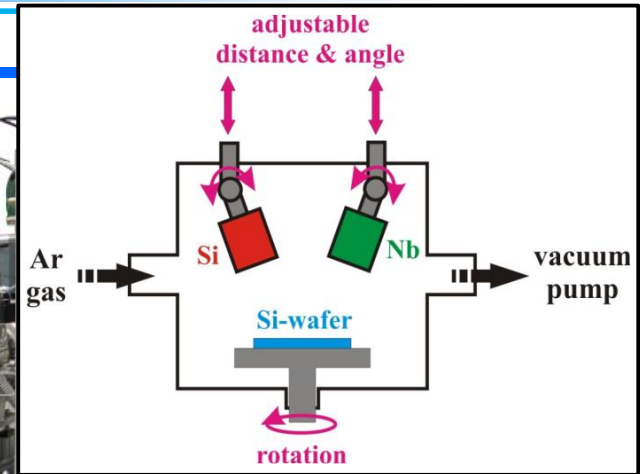


2 parameter to optimize :
JAWS : $x \approx 20\%$, $d_{NbSi} \approx 30$ nm @ 15 GHz

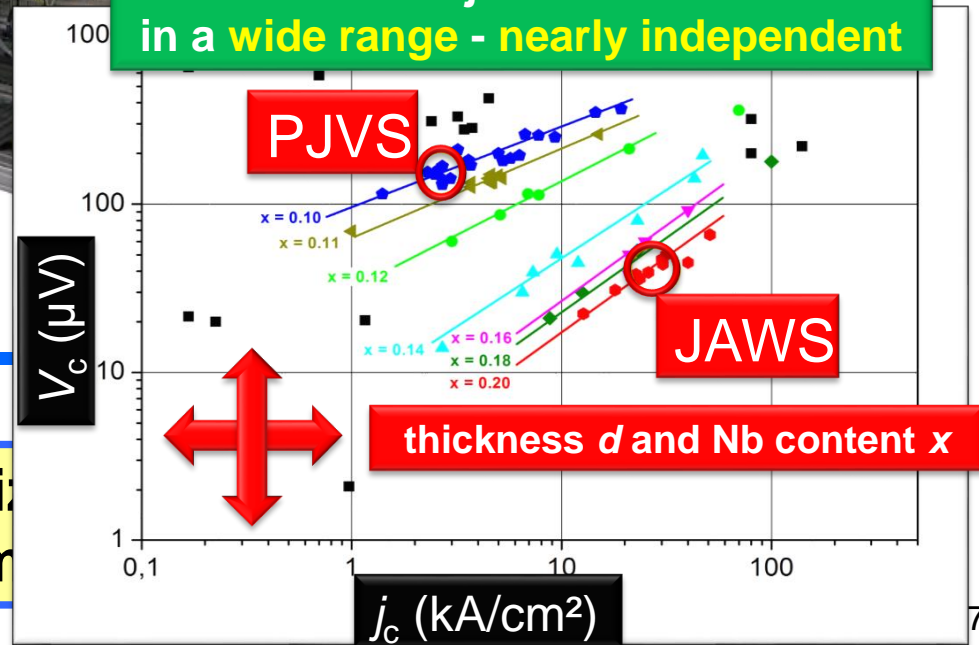
UNIVEX 450C – Cluster - Sputter - System



SNS junctions : Nb_xSi_{1-x}



adjustable in a wide range - nearly independent



2 parameter to optimize
JAWS : $x \approx 20\%$, $d_{NbSi} \approx 30$ nm

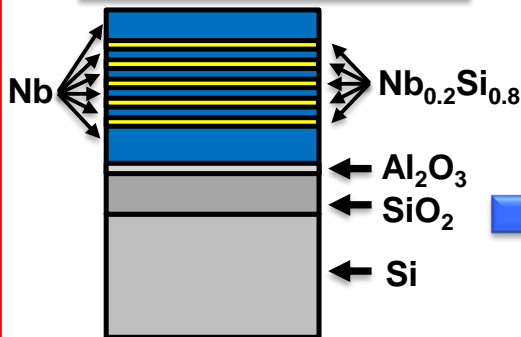
Technology: 5-stacked Jos. junctions



12 layer in-situ,
15 layer total

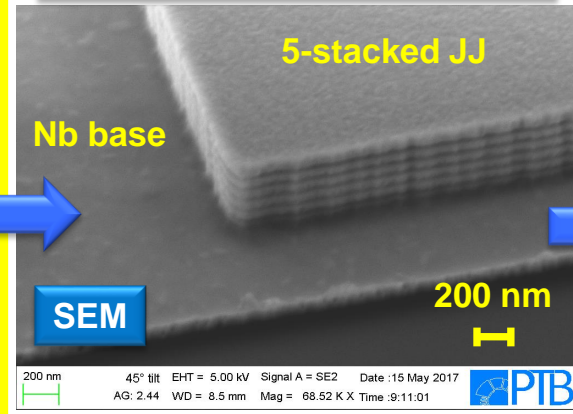
stacks : „high“ integration density

1) layer sequence

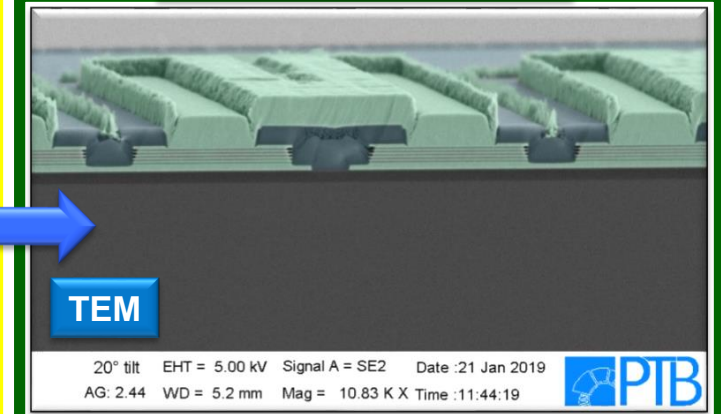


not shown : 1) Nb wire,
2) AuPd resistors, 3) SiO₂ isolation

2) after two fabrication steps



3) fabrication finished



JJ parameter :

- chain length : 3000...4000 JJ
- Nb_{0.2}Si_{0.8} : deposited by co-sputtering
- critical current density : $j_c \approx 5 \text{ kA/cm}^2$
- normal resistance : $R_n \approx 3 \text{ m}\Omega$
- characteristic voltage : $V_c \approx 10 \text{ }\mu\text{V}$

modified fabrication of 5-stacked JJ :

- “window” process adjusted for stacks :
 - resist thickness
 - e-beam dose and proximity correction
 - development times
 - SiO₂ and Nb-Wiring layer thickness
 - implementation of CMP for SiO₂
- RIE-ICP : JJ stacks with steep edges
- PECVD : thick SiO₂ isolation layer
- window etch : in 2 steps !

summary of process :

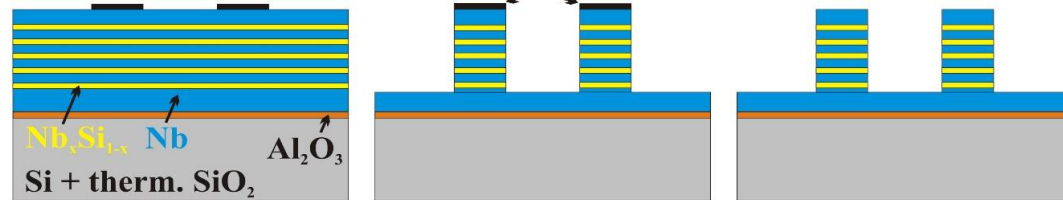
- 5 x deposition
- 7 x etching
- 7 x e-beam
- 1 x UV-lithography
- 1 x lift off
- 6 main fabrication steps
→ next slide

Technology :

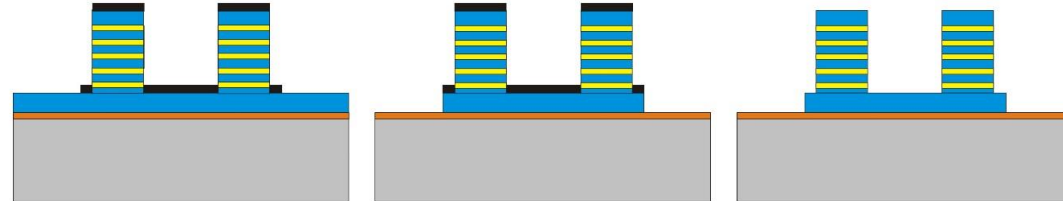
SNSNSNSNSNS



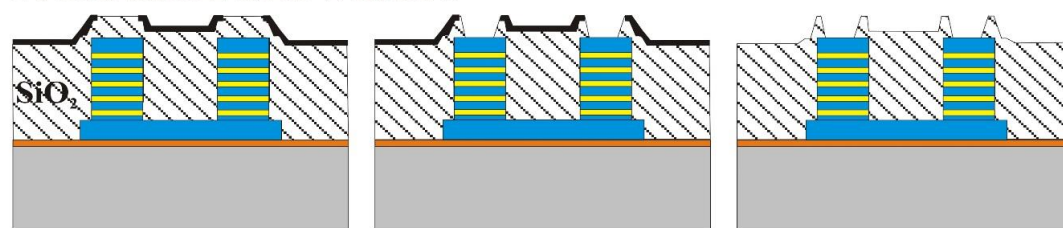
1. Josephson junction



2. Base electrode



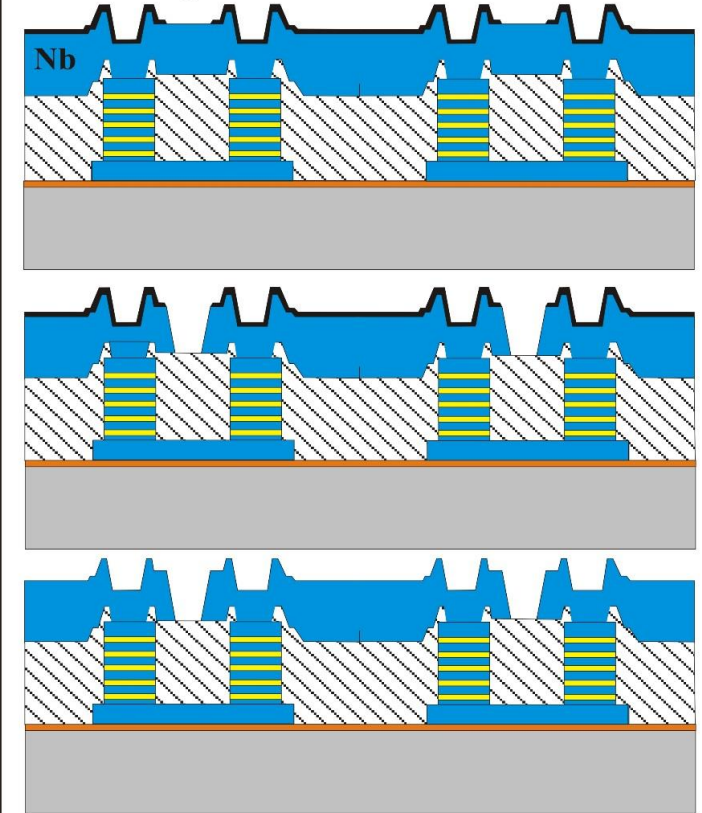
3. Isolation and window



5. Load : AuPd resistors by "lift-off"

→ detailed process : ca. 40 fabrication steps
→ clean-room cycle-time 2 wafer : ca. 3 weeks

4. Wiring electrode



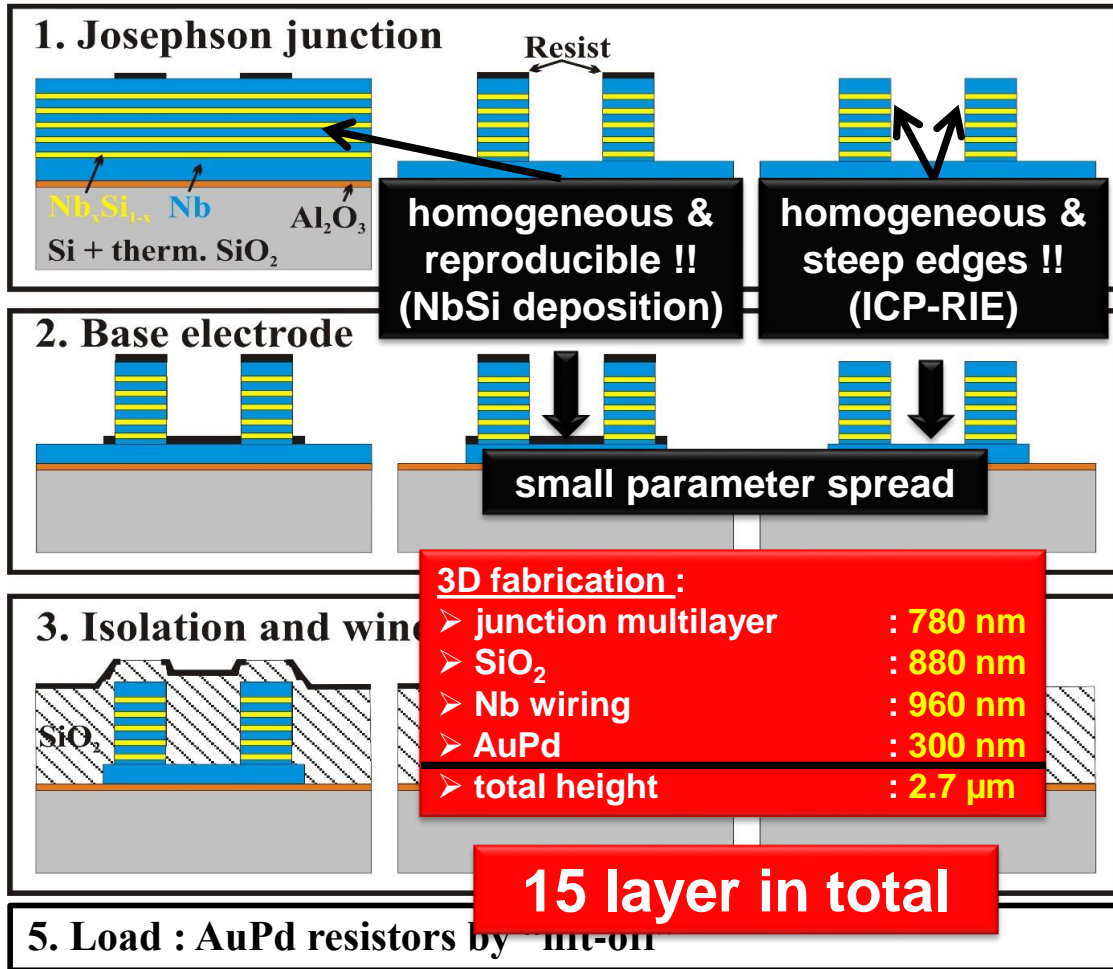
6. Pads : SiO₂ by ICP-RIE

only for 5-stacked JJ :
Improvement of yield !



Technology :

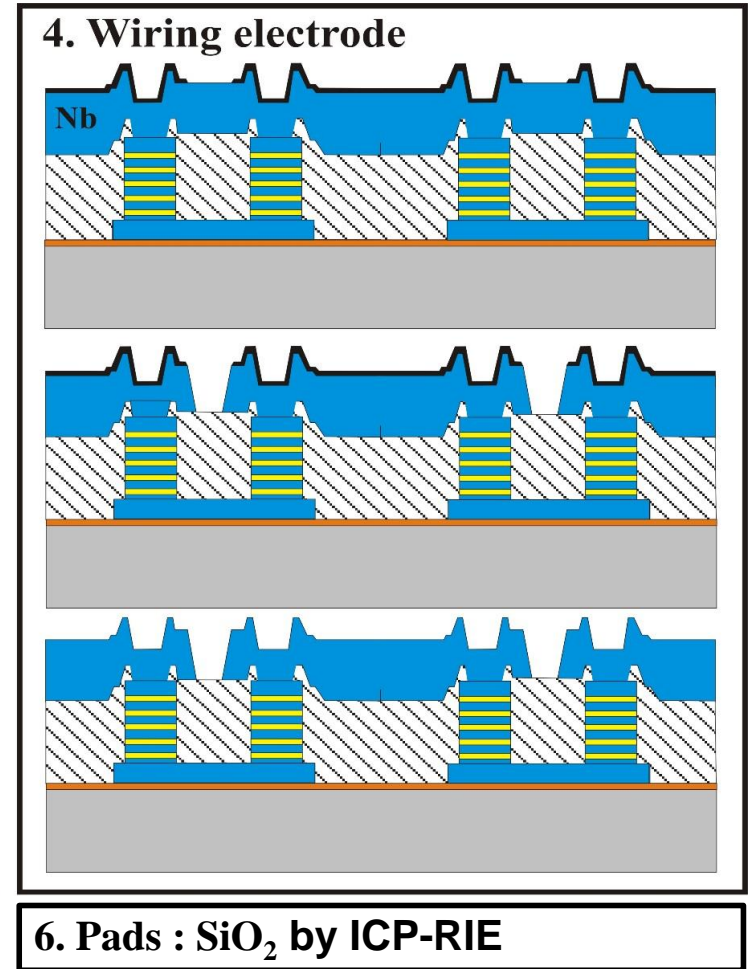
SNSNSNSNSNS



3D fabrication :

➤ junction multilayer	: 780 nm
➤ SiO ₂	: 880 nm
➤ Nb wiring	: 960 nm
➤ AuPd	: 300 nm
➤ total height	: 2.7 μm

15 layer in total



→ detailed process : ca. 40 fabrication steps
 → clean-room cycle-time 2 wafer : ca. 3 weeks

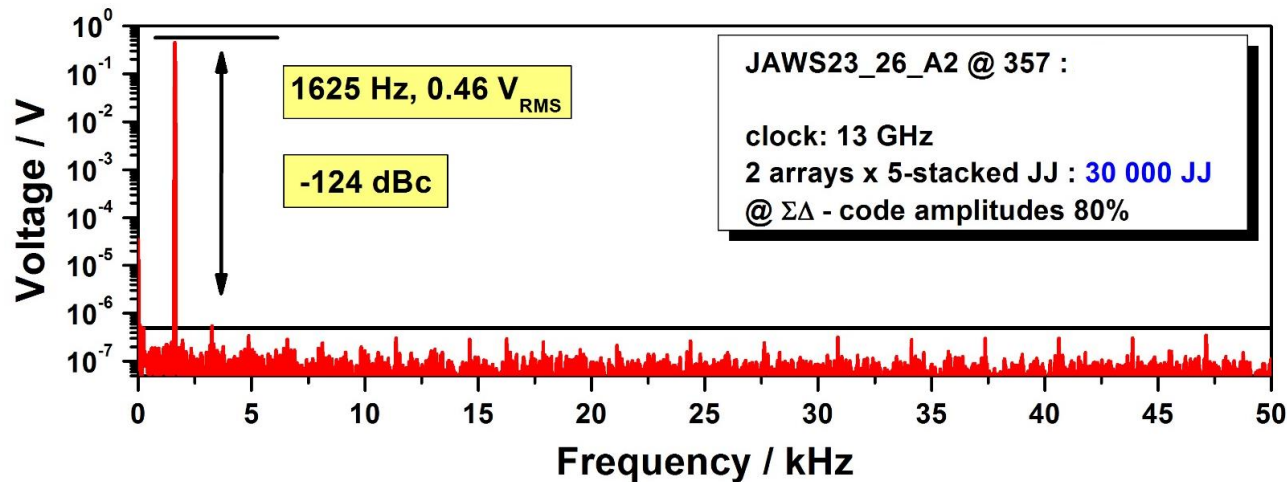


only for 5-stacked JJ :
 Improvement of yield !

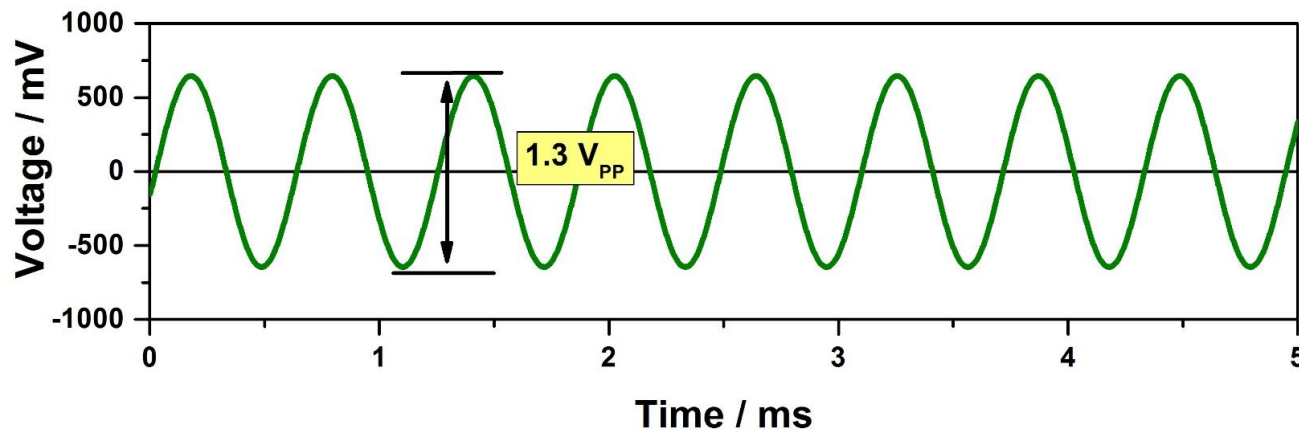
5-stacked Josephson junctions



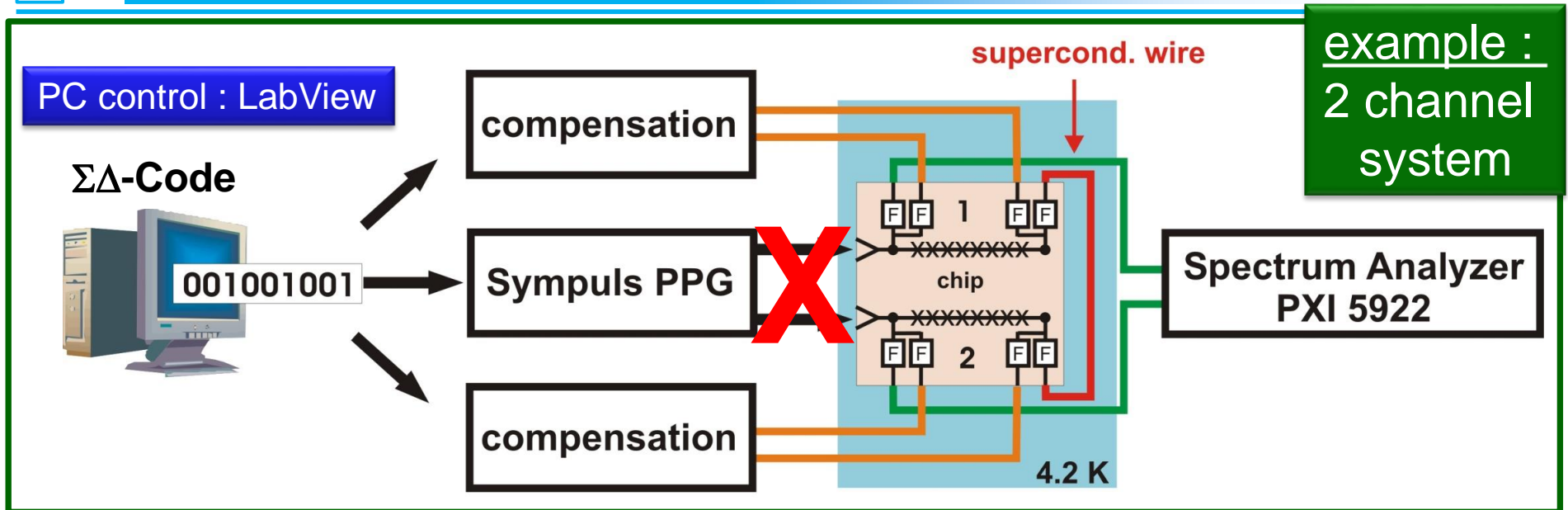
30 000 junctions per chip : ca. 0.5 V RMS / 1.3 V_{PP}



**2 arrays
@ 1 chips
with
30 000 junctions**



JAWS setup : electrical pulses



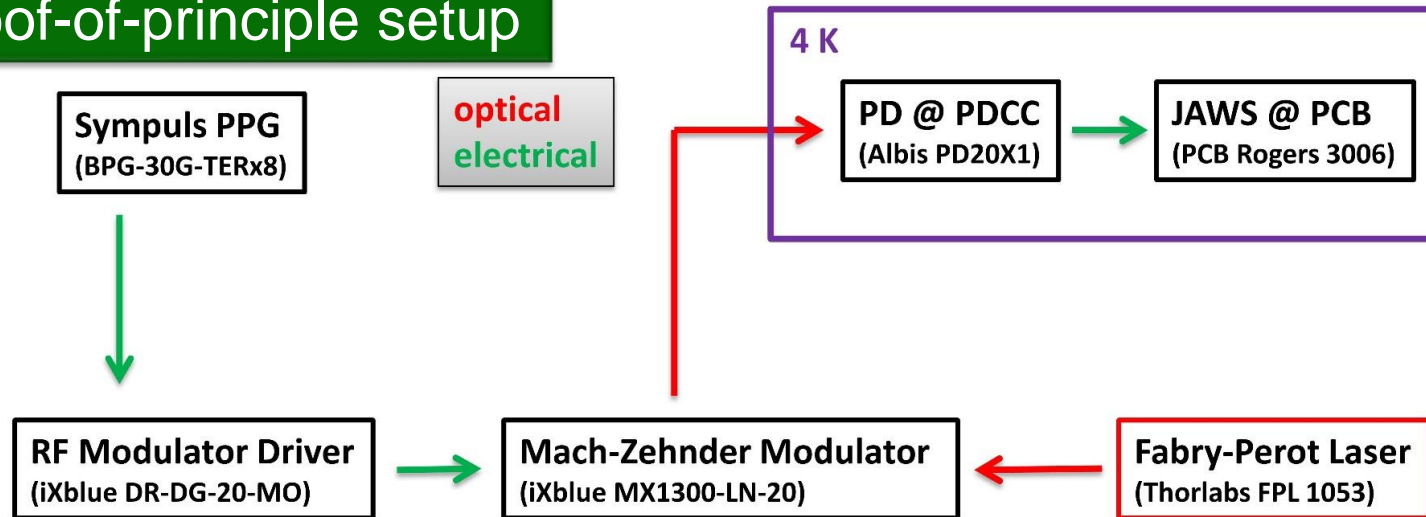
no electrical pulses anymore

- optical pulses : **photodiodes @ 4.2 K** “direct” (hybrid) on-chip
- use of **optical fibers** → less noise @ MHz-range
- easy **parallel** optical HF-channels → low cost solution

JAWS setup : optical pulses



proof-of-principle setup

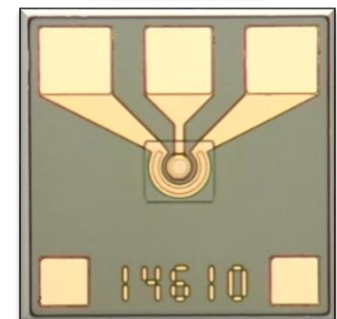


high-speed lensed photodiode (PD)



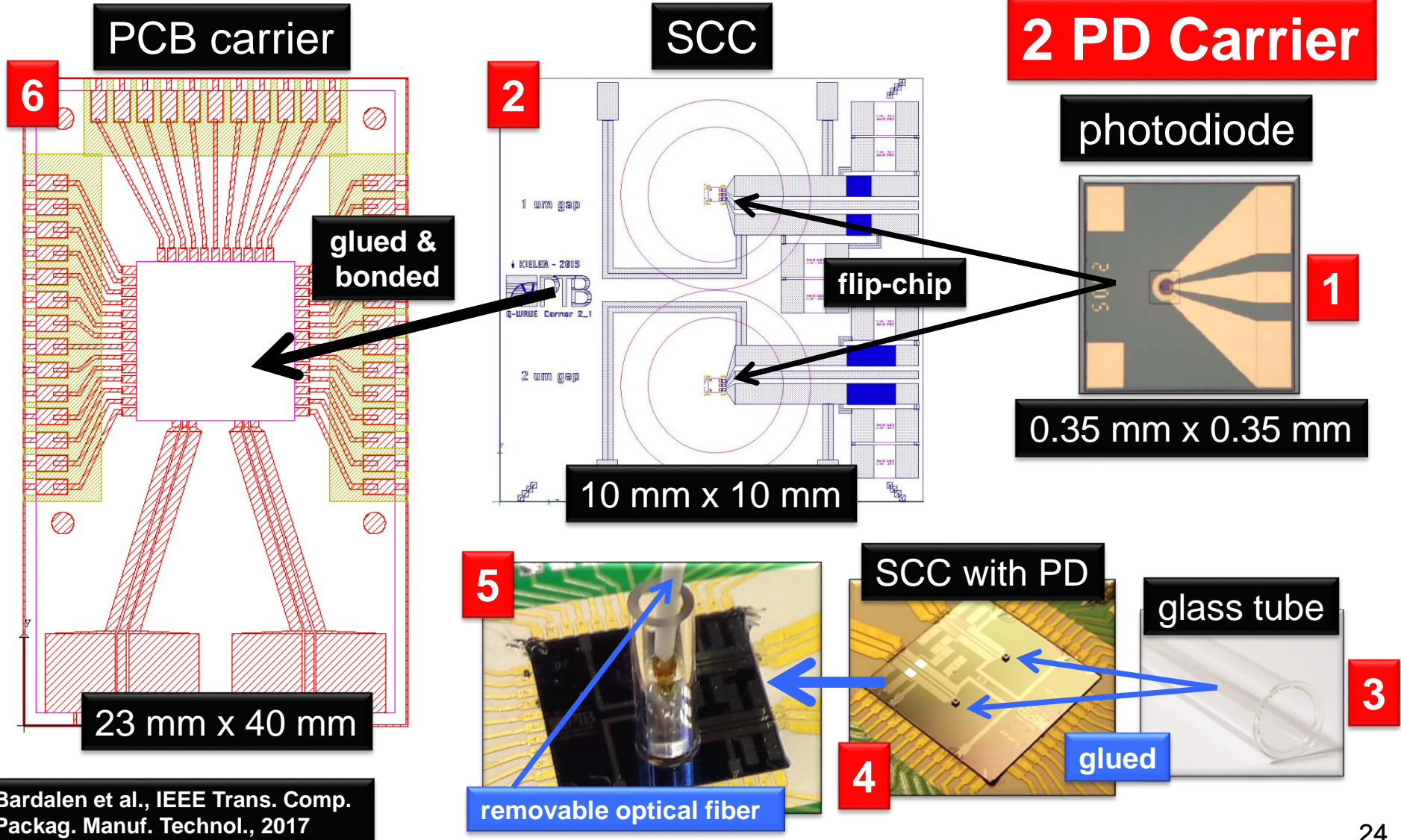
- PDCS24L (InGaAs/InP) chip with a tapered CPW
- **integrated backside lens** (bottom illuminated)
- up to **28 Gb/s**, laser 1310 nm
- easy and efficient optical coupling
- pad layout allowing **flip-chip mounting**

ALBIS



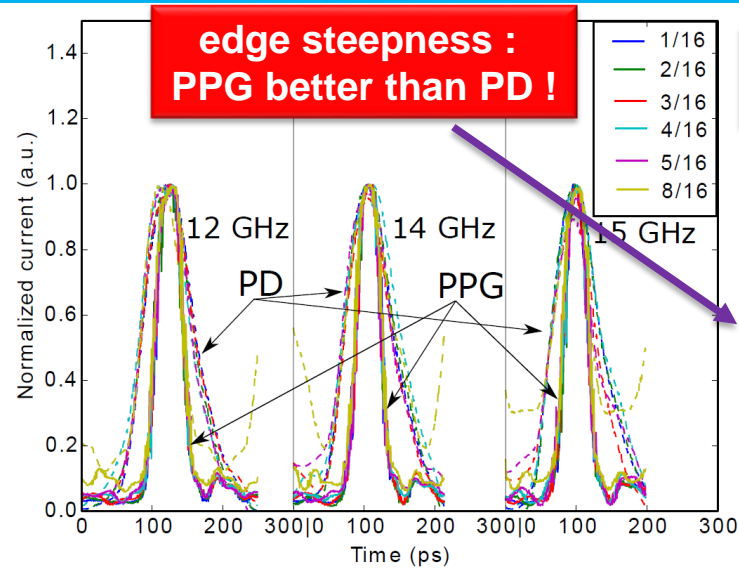
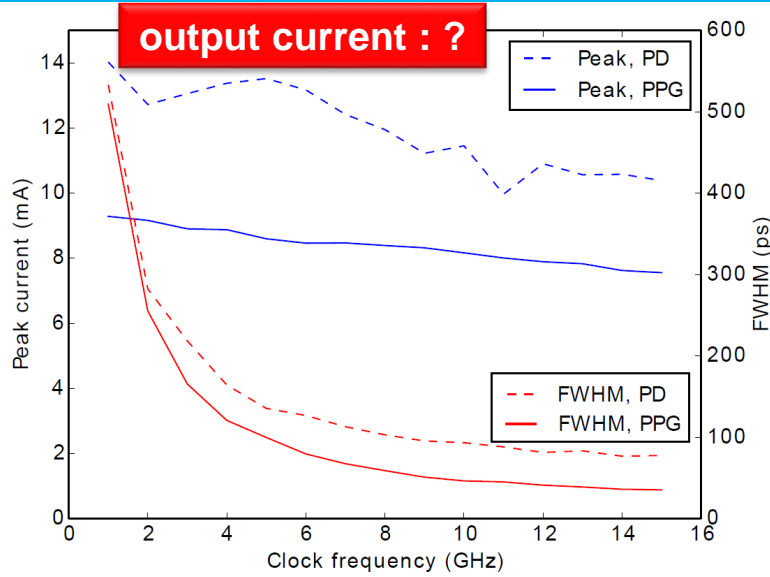
<http://www.albisopto.com>

Mounting of PD's and tube @ USN, JV



Bardalen et al., IEEE Trans. Comp. Packag. Manuf. Technol., 2017

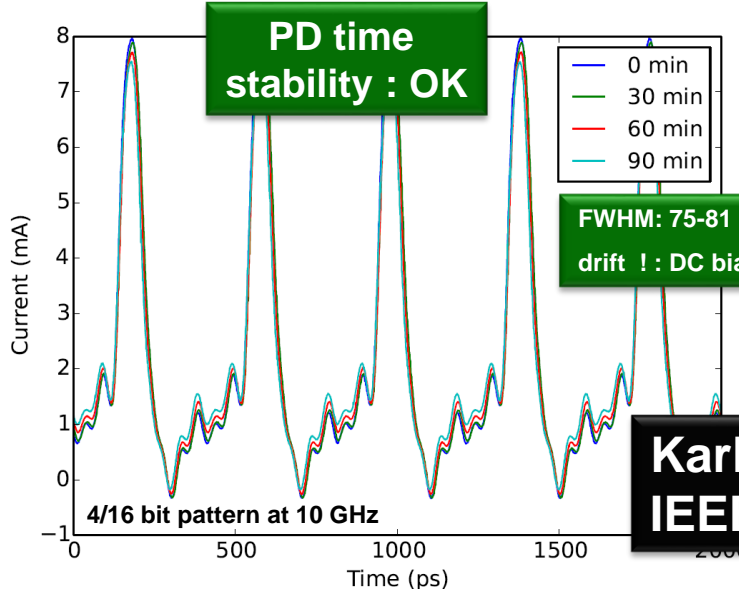
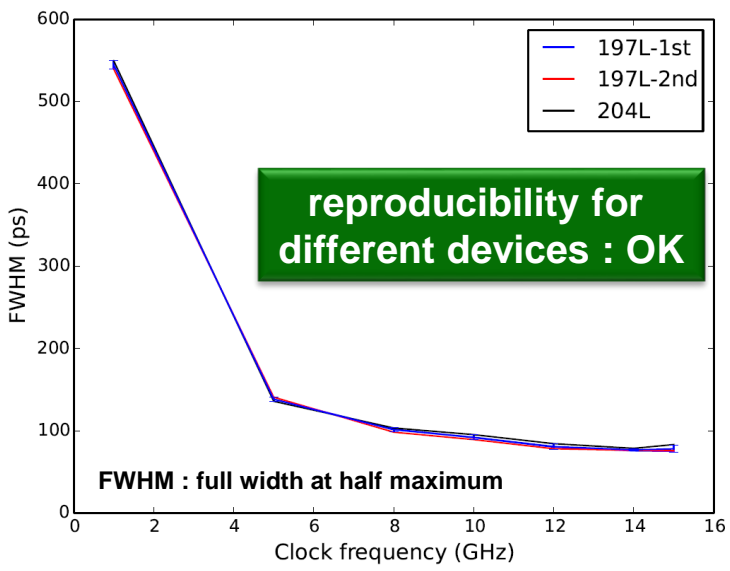
PD's @ 4 K: HF-characterization



measurements made @ PTB



problem for maximum pulse rate !?

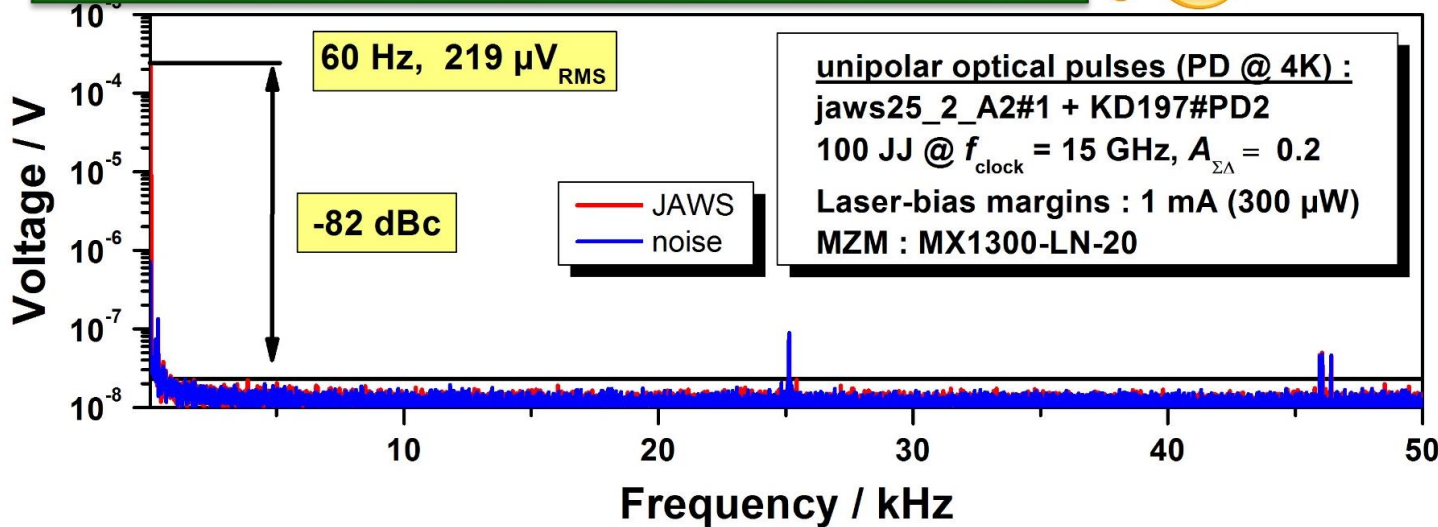


Karlsen, et al. : IEEE TAS, 2019

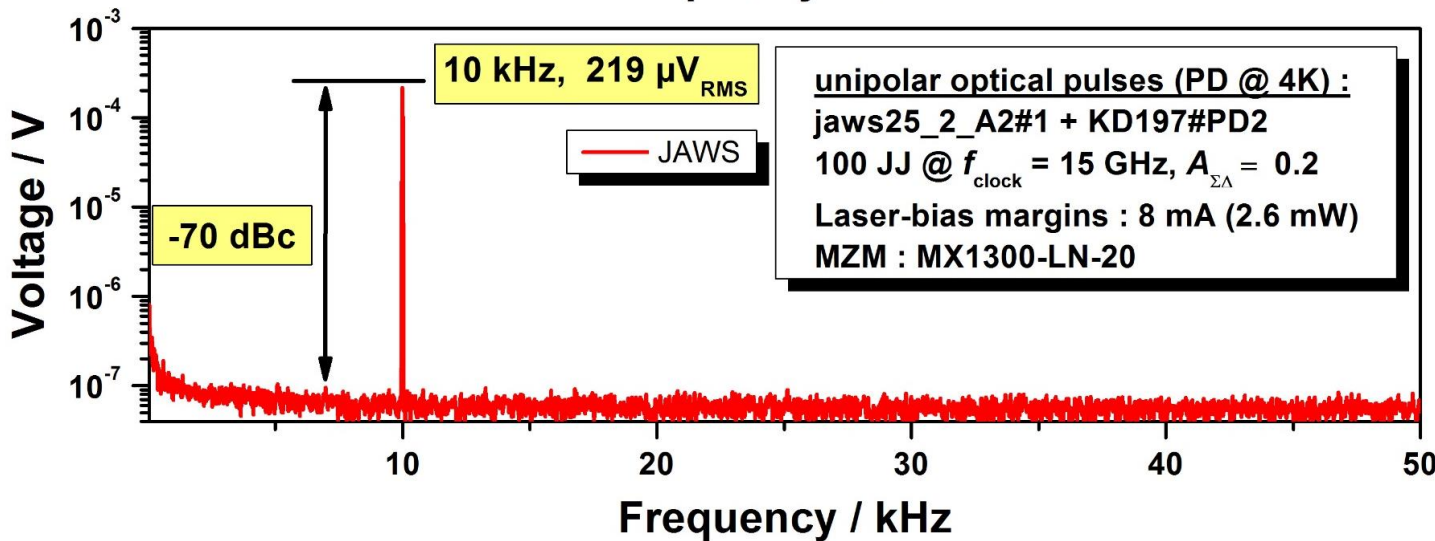
optical JAWS: signal frequency



spectrally pure waveforms synthesized



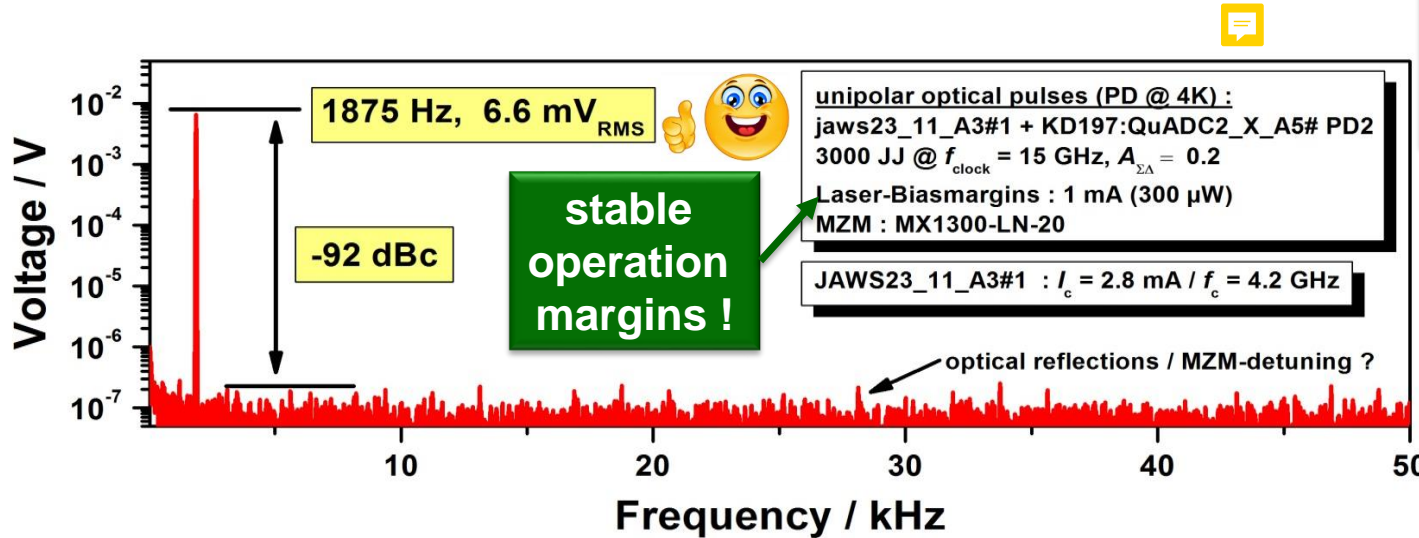
signal frequencies
60 Hz
&
10 kHz



$f_{\text{clock}} = 15 \text{ GHz}$

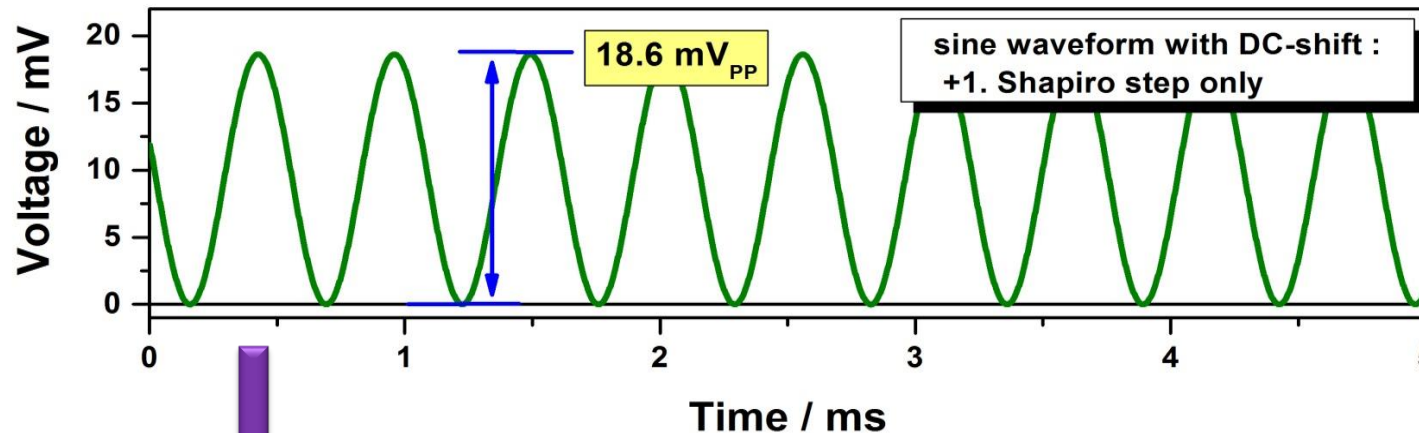
„full speed“

optical JAWS : number of junctions



JAWS with 3000 junctions

signal frequency 1875 Hz



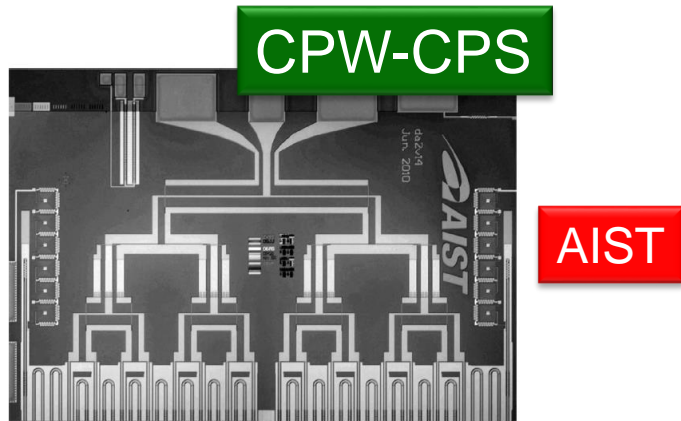
$f_{\text{clock}} = 15 \text{ GHz}$
&
 $A_{\Sigma\Delta} = 20\%$

„full speed“

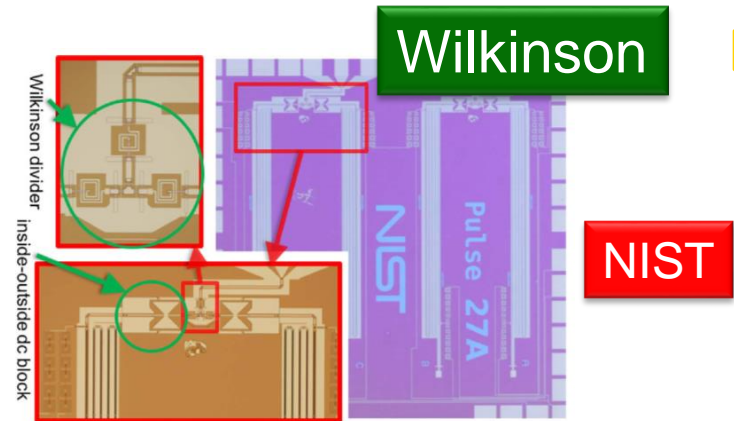
1 PD → unipolar operation → +1.SS only : DC-shift

Kieler, et al. :
IEEE TAS, 2019

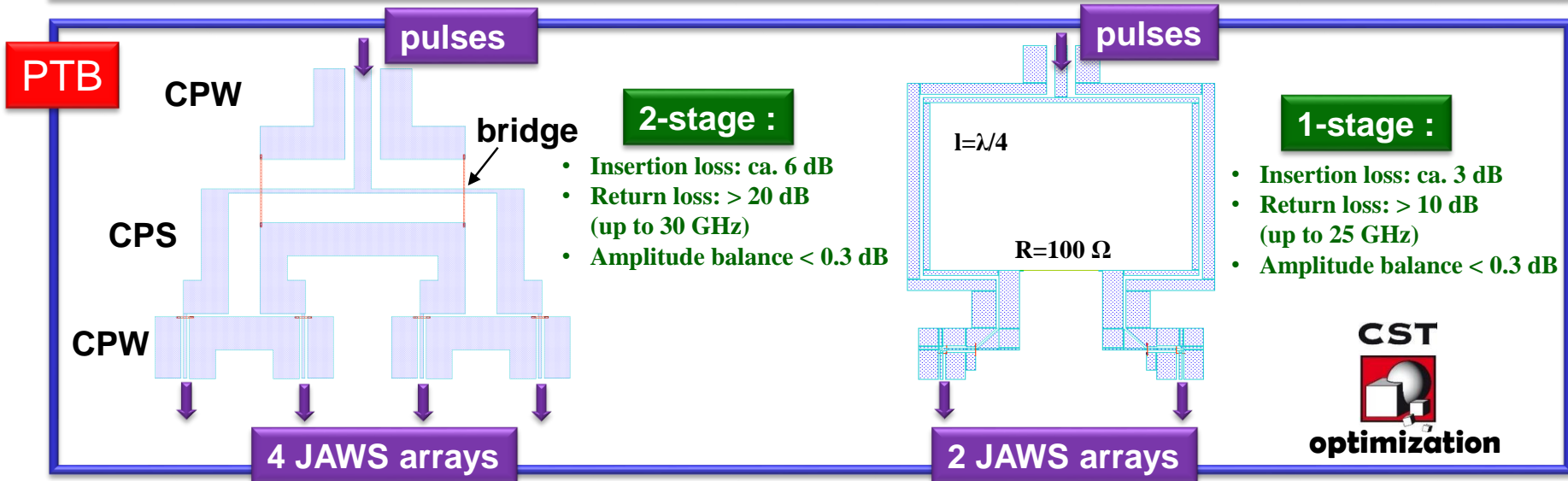
On-chip power splitter



H. Yamamori and S. Kohjiro, *IEEE Trans. Appl. Supercond.*, Dec. 2016



N. E. Flowers-Jacobs, et al., *IEEE Trans. Appl. Supercond.*, Sep. 2016

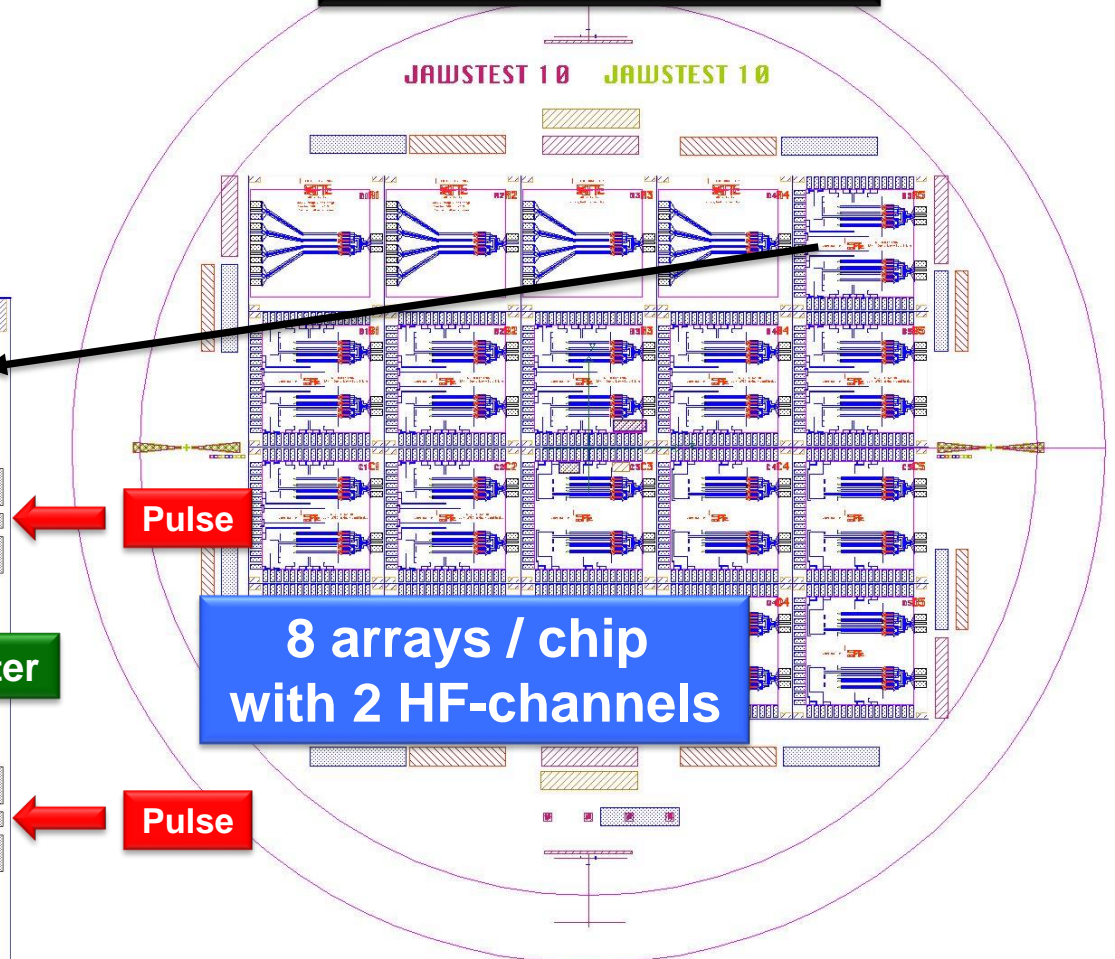
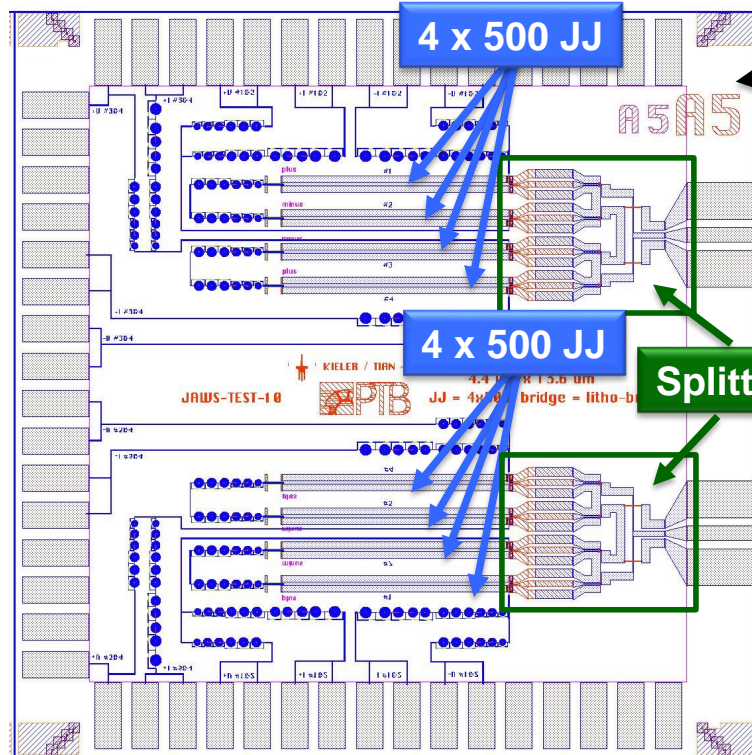


CPW-CPS splitter : layout

Design „JAWSTEST 10“ :

- chip size: 10 mm × 10 mm
- 2 arrays @ chip
- 4 chains @ array
- 500 JJs @ chain
- CPW: 50 Ohm
- CPW taper

3 inch Wafer Layout



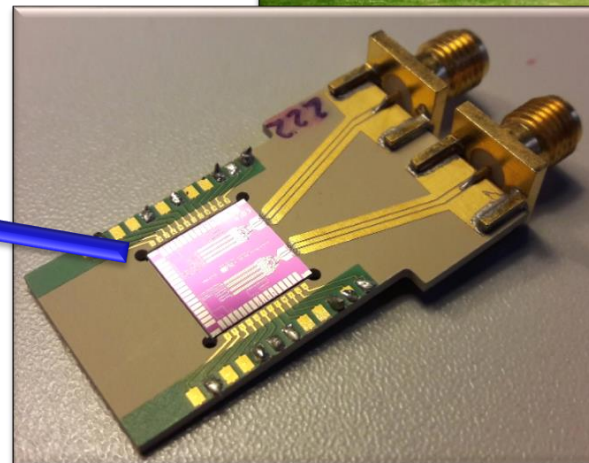
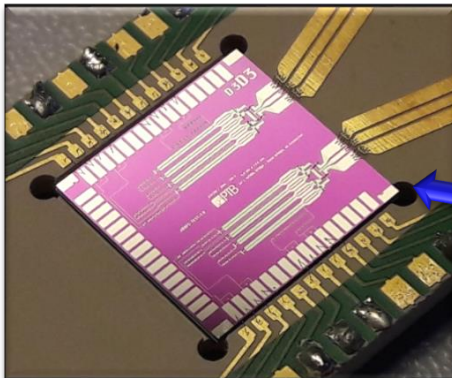
CPW-CPS splitter : fabrication



Design „JAWSTEST 10“ :

- chip size: 10 mm × 10 mm
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- 500 JJs @ chain
- CPW: 50 Ohm
- CPW taper

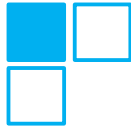
JAWS Chip



PTB clean room



- SNS junctions: $\text{Nb}_x\text{Si}_{1-x}$
- standard window process



CPW-CPS splitter : IVC comparison



3) IVC vs. pulse frequency



“standard” JAWS Array

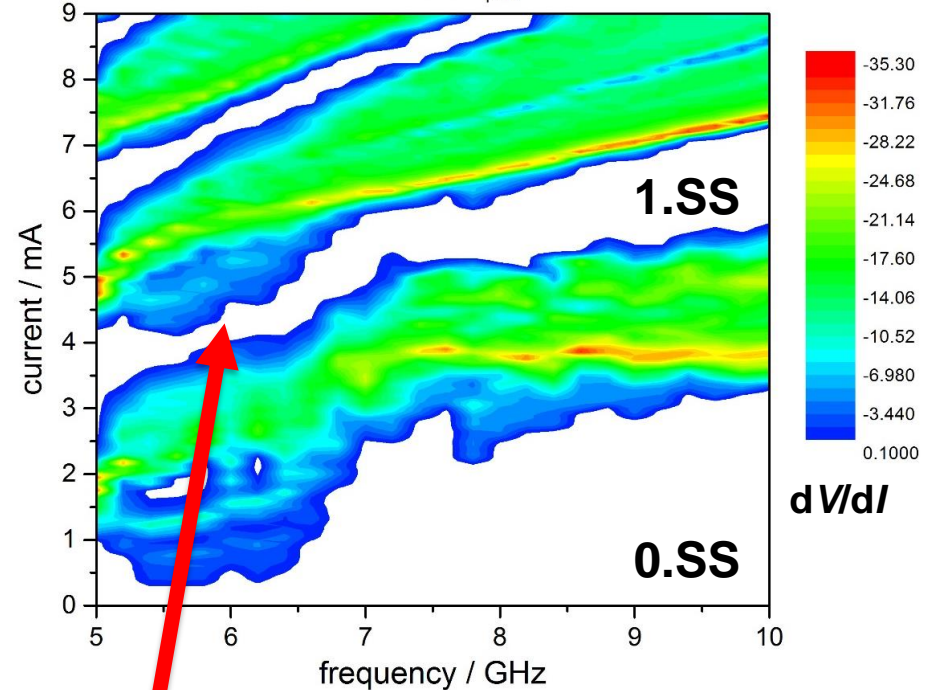
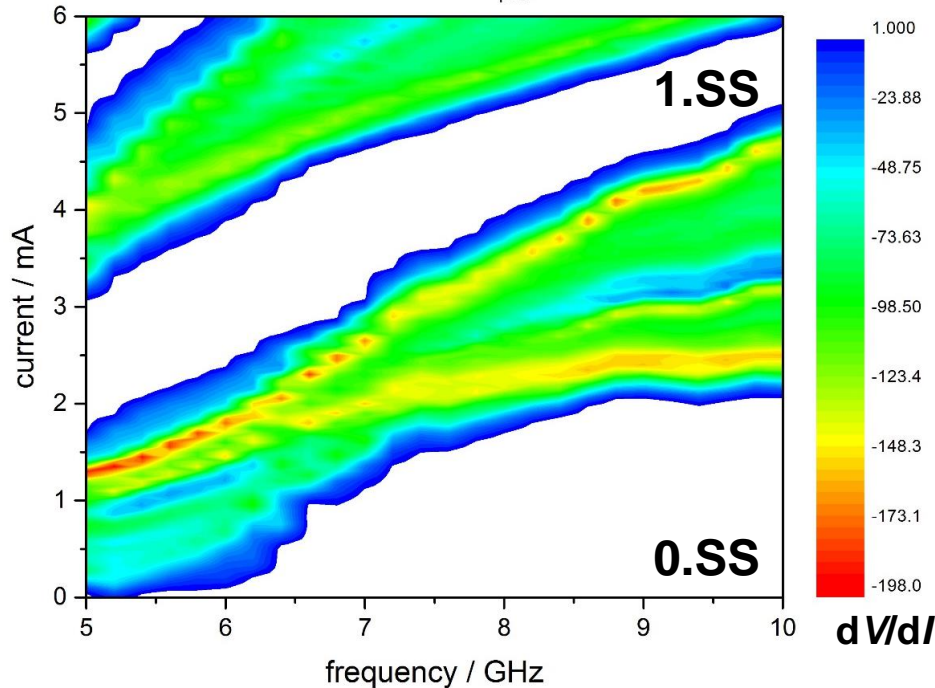
4 parallel JAWS Arrays

12 000 junctions (4-stacked)

2 000 junctions (non-stacked)

jaws23_10_A4#2 : $A_{puls} = 2000$

jawstest10_1_C3#1 : $A_{puls} = 2000$



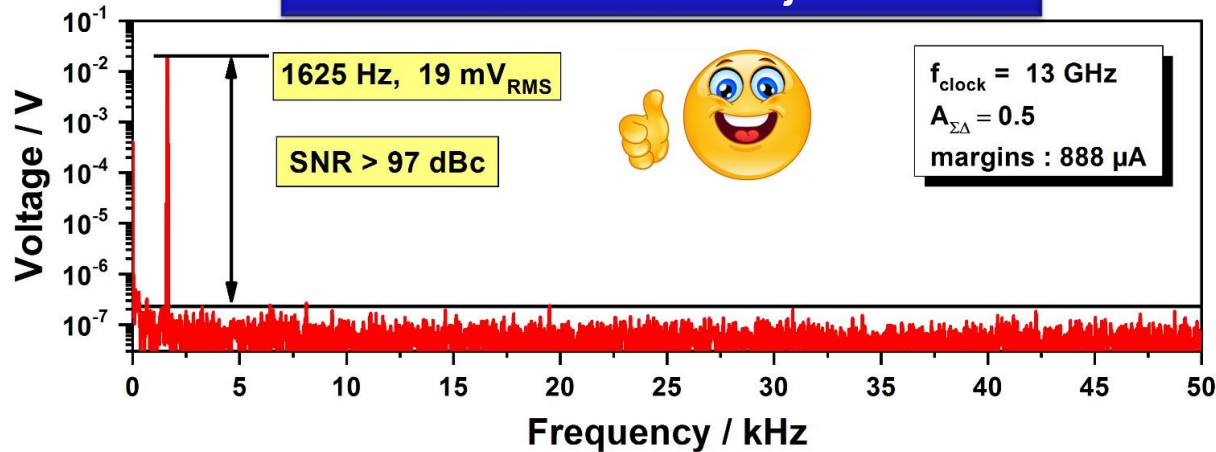
Shapiro step reduced

CPW-CPS splitter : waveform synthesis



4) synthesis sinus-waveform

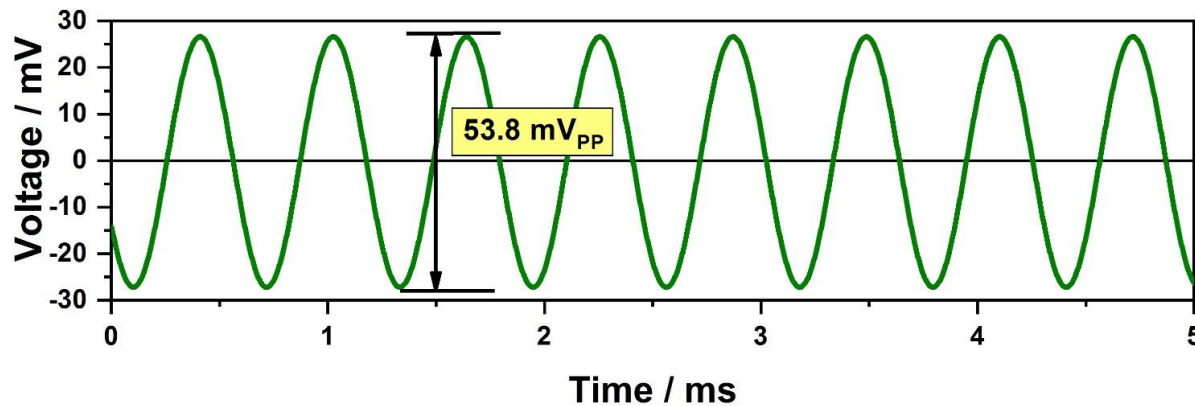
2000 non-stacked junctions



pulse amplitude
not sufficient

max. clock frequency
13 GHz (not 15 GHz !)

spectrum OK,
and $A_{\Sigma\Delta} = 0.6$



4 parallel arrays

Design : 3rd generation

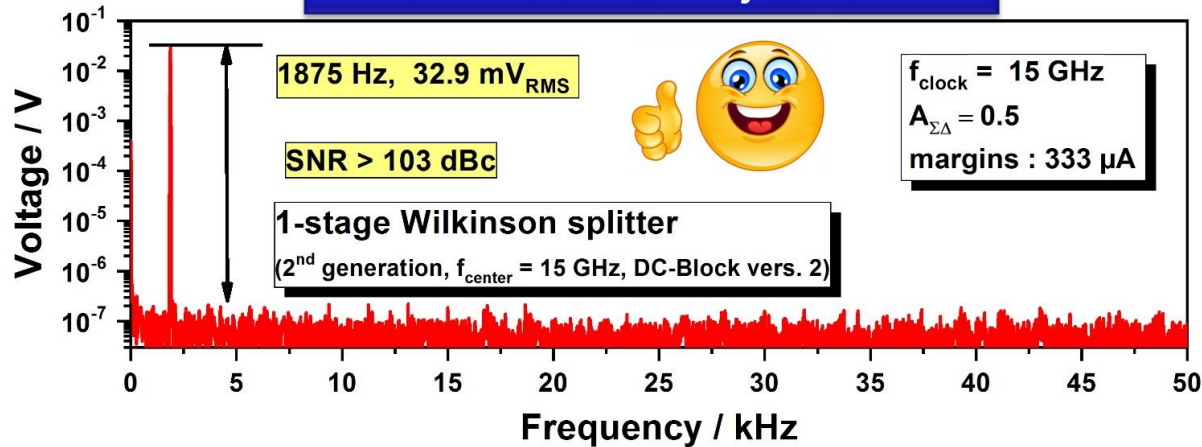
Wilkinson splitter : waveform synthesis



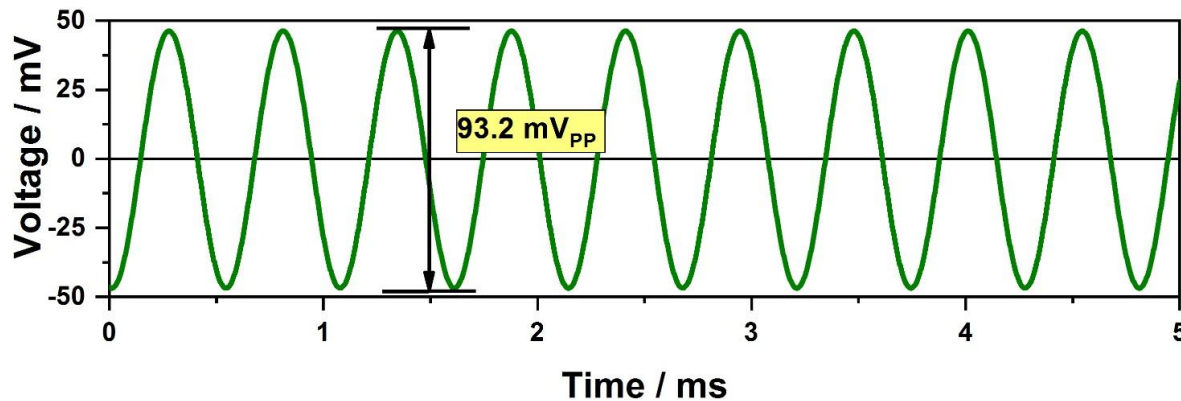
4) synthesis sinus-waveform

3000 3-stacked junctions

max. clock frequency
15 GHz



spectrum OK
and $A_{\Sigma\Delta} = 0.5$

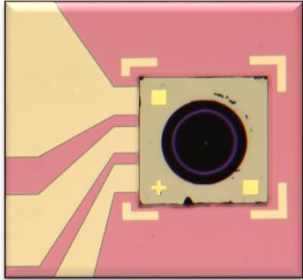


Tian, et al. :
subm. to
IEEE TAS, 2019

2 parallel arrays

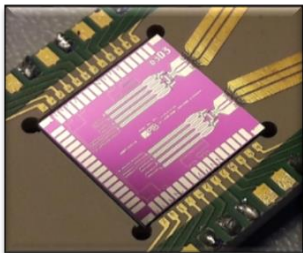
Design : 2nd generation

Summary and outlook



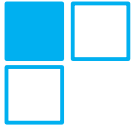
optical pulse drive

- **Si-carrier chip (SCC)** for photodiodes (PD) developed and fabricated
- PD @ SCC by **flip-chip** established
- **easy-mount** for **optical fiber** by glass tube developed
- operation of **PD @ SCC and JAWS-chip @ 4.2 K**
- spectrally **pure unipolar waveforms** synthesized
- **next step : bipolar operation and higher integration density of PD's**

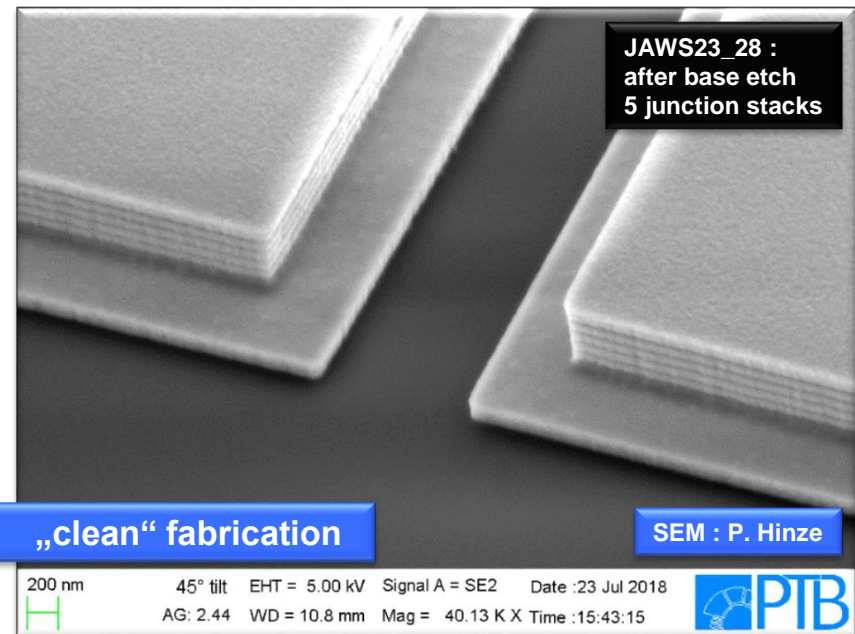
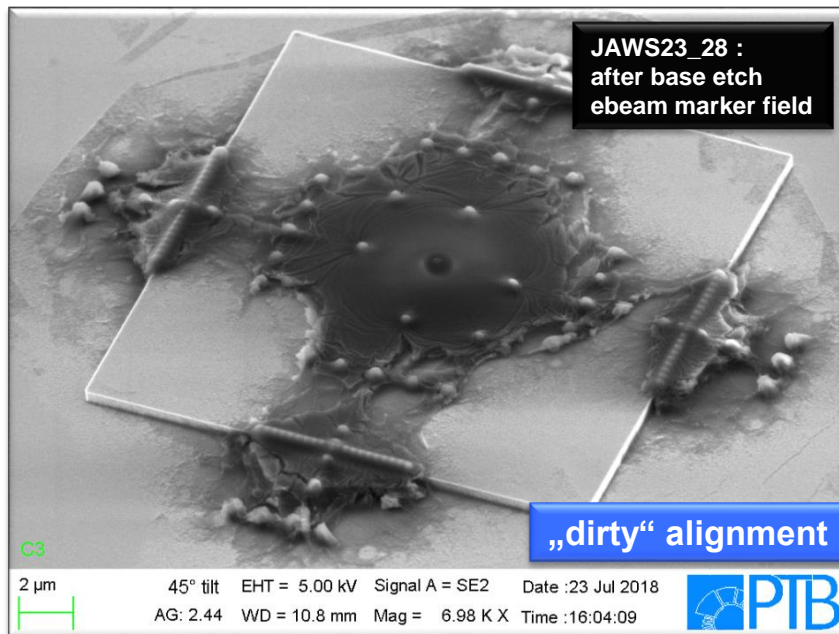


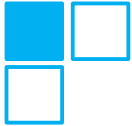
power splitter

- on-chip **CPW-CPS-** and **Wilkinson-splitter** optimized by simulations
- fabrication of JAWS circuits with up to **3000 3-stacked junctions**
- spectrally **pure bipolar waveforms** with **both splitter types**
- **next step : more junctions and 2-stage Wilkinson-splitter**



Thank you
very much
for your attention !





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